



United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FI	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/717,068	11/22/2000		In-Jea Chung	8733.329.00	2403
30827	7590	10/21/2003		EXAMINER	
MCKENNA 1900 K STR		& ALDRIDGE LL	SCHECHTER, ANDREW M		
WASHINGTON, DC 20006				ART UNIT	PAPER NUMBER
			•	2021	

DATE MAILED: 10/21/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

			V
	Application N .	Applicant(s)	
	09/717,068	CHUNG ET AL.	
Office Action Summary	Examiner	Art Unit	
	Andrew Schechter	2871	
The MAILING DATE of this communication ap Period for Reply	pears on the cover sheet wit	th the correspondence ad	dress
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1. after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reg - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statul - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status	136(a). In no event, however, may a reply within the statutory minimum of thirty will apply and will expire SIX (6) MON te, cause the application to become AB.	eply be timely filed (30) days will be considered timely FHS from the mailing date of this co ANDONED (35 U.S.C. § 133).	: mmunication.
1) Responsive to communication(s) filed on 31	July 2003 .		
2a)⊠ This action is FINAL . 2b)□ T	his action is non-final.		
3) Since this application is in condition for allow closed in accordance with the practice under			e merits is
Disposition of Claims			
4) Claim(s) <u>1-20</u> is/are pending in the applicatio			
4a) Of the above claim(s) is/are withdra 5) Claim(s) is/are allowed.	awn from consideration.		
6)⊠ Claim(s) <u>1-20</u> is/are rejected.			
7) Claim(s) is/are objected to.			
8) Claim(s) are subject to restriction and/	or election requirement.		
Application Papers			
9)☐ The specification is objected to by the Examin	er.		
10)☐ The drawing(s) filed on is/are: a)☐ acce	epted or b) objected to by the	ne Examiner.	
Applicant may not request that any objection to the	= : :	• •	
11)☐ The proposed drawing correction filed on		sapproved by the Examine	er.
If approved, corrected drawings are required in re	• •		
12) The oath or declaration is objected to by the E	xamıner.		
Priority under 35 U.S.C. §§ 119 and 120			
13) Acknowledgment is made of a claim for foreig	in priority under 35 U.S.C. §	119(a)-(d) or (f).	
a)⊠ All b)□ Some * c)□ None of:		•	
1. ☐ Certified copies of the priority documen			
2. Certified copies of the priority document	·	•	01
 3. Copies of the certified copies of the pricapplication from the International B * See the attached detailed Office action for a lis 	ureau (PCT Rule 17.2(a)).		Stage
14) Acknowledgment is made of a claim for domes	tic priority under 35 U.S.C.	§ 119(e) (to a provisional	application).
a) The translation of the foreign language pr			
Attachment(s)			
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of I	Summary (PTO-413) Paper No(Informal Patent Application (PTC	

Art Unit: 2871

DETAILED ACTION

Response to Arguments

1. Applicant's arguments filed 31 July 2003 have been fully considered but they are not persuasive.

The applicants argue that the teaching of *Yamamoto* is improperly applied to the device of *Harada*, since *Yamamoto* invention [in Figs. 3 and 4] is presented as an improvement over prior art [in Figs. 1 and 2] which is an injection method, which allegedly is "entirely different" [p. 6] from the method of *Harada*. This is not persuasive to the examiner, since the two methods are sufficiently similar that the motivations for using *Yamamoto's* method (including being able "to remove excessive liquid crystal" and seal the panel so "the sealing resin is not spread" [see previous Office Action, p. 4]) apply to both *Yamamoto's* prior art and the method of *Harada*. One of ordinary skill in the art, having *Yamamoto's* teaching, would therefore have found it obvious to apply it to the method of *Harada*, so the previous rejections are maintained.

The applicants argue, regarding claim 12, that "there is no reason or motivation ... [to] expect the heat-treated, nematic phase FLC material of <u>Harada et al.</u> to exhibit a viscosity of "20 to 50 mm²/sec," as asserted by the Examiner" [p. 8] The examiner never asserted this. Instead, the examiner asserted that "*Harada*'s heat-treating activates the liquid crystal material to have <u>substantially the same characteristics</u> as a liquid crystal material having a viscosity of 20 to 50 mm²/sec" [p. 5 of the previous Office Action, emphasis added] where the examiner explicitly interpreted the underlined

Art Unit: 2871

phrase "to mean that the material flows easily to distribute itself within the liquid crystal cell" [also p. 5]. *Harada* clearly discloses this as discussed in the rejection, so the previous rejections are maintained.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 3, 4, 5, and 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Harada et al.*, U.S. Patent No. 5,361,152 in view of *Yamamoto*, Japanese Patent Document No. 59-195222 and *Mochizuki et al.*, U.S. Patent No. 5,348,685.

Harada discloses a fabricating method for a LCD comprising providing two substrates [1, 4], forming orientation films on them [col. 3, lines 1-4], depositing a liquid crystal material [col. 3, line 52 – col. 4, line 1], forming a seal material [2] at the edges of one substrate, attaching the substrates [col. 5, lines 34-35], and heat-treating the liquid crystal material to lower the viscosity [col. 5, lines 40-45].

Harada does not disclose forming a seal material after depositing the liquid crystal material. Also, Harada deposits high viscosity ferroelectric liquid crystals and heat-treats them to lower their viscosity to the nematic viscosity range, but does not

Art Unit: 2871

disclose explicit values of the viscosities of the liquid crystal when it is deposited to compare to the claimed ranges.

On the first point, *Yamamoto* does disclose forming a seal material after depositing the liquid crystal [see the series of steps in Fig. 3]. It would be obvious to one of ordinary skill in the art to use the method of *Yamamoto* in making the device of *Harada*, motivated by *Yamamoto's* teaching that this method makes it possible "to remove excessive liquid crystal" and seal the panel so that "the sealing resin is not spread" and a "wide display window can be obtained" [see p. 5 of the translation]. (The examiner notes that these are advantages over the reverse order, placing the seal down first; *Yamamoto* also offers additional advantages in this passage over the injection method.)

Still on the first point, the examiner notes two differences between the method of *Yamamoto* and that of the present specification: in the present invention, the seal is placed on the first substrate before the substrates are attached to each other, while *Yamamoto* attaches them and then adds the seal; and the seal in the present invention is between the two substrates, while in *Yamamoto* it is on one substrate and outside the other substrate.

On the second point, *Mochizuki* discloses ferroelectric liquid crystal compositions for use in analogous LCDs, and also explicitly discloses the viscosities of these compositions. In Table 2, *Mochizuki* discloses the room temperature viscosities of various ferroelectric liquid crystal compositions, which range from 170 – 1020 mPa·sec (note that 1 mPa·sec is approximately equal to 1 mm²/sec, as discussed on p. 3 of the

Art Unit: 2871

previous Office Action, so that these viscosities certainly lie within the recited ranges of greater than about 20-50 mm²/sec or greater than 100 mm²/sec). It would be obvious to one of ordinary skill in the art to use one of the ferroelectric liquid crystal compositions of *Mochizuki*, motivated by *Mochizuki*'s teaching that this provides "a ferroelectric material generating a high-quantity [sic] image and excellent response characteristics" [col. 28, lines 32-44]. Claims 1 and 5 are therefore unpatentable.

Harada discloses heat-treating after attaching the substrates, and using a roller or dispenser to print the ferroelectric liquid crystal [col. 3, lines 51-55], so claims 3, 4, and 7 are also unpatentable.

4. Claims 6, 12, 14, and 15 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Harada* in view of *Yamamoto* and *Mochizuki*, as applied to claims 1, 3, 4, 5, and 7 above.

The additional limitation of claims 6 and 12, over the claims previously discussed, is that the heat-treating activates the liquid crystal to have substantially the same characteristics as a liquid crystal material having a viscosity of 20 to 50 mm²/sec. The specification is silent on the question of what "substantially the same characteristics" means; in the context of this invention, the examiner interprets this to mean that the material flows easily to distribute itself within the liquid crystal cell.

As discussed above, *Harada* discloses heat-treating the liquid crystal material to have it change into a nematic phase, in order to render the liquid crystal homogeneous (by lowering the viscosity and allowing the material to flow easily into a uniform configuration) [col. 5, lines 21-45]. Therefore, following this interpretation, *Harada*'s

Art Unit: 2871

heat-treating activates the liquid crystal material to have substantially the same characteristics as a liquid crystal material having a viscosity of 20 to 50 mm²/sec, so claims 6 and 12 are also unpatentable.

Harada discloses using a roller or dispenser to print the ferroelectric liquid crystal [col. 3, lines 51-55], so claims 14 and 15 are also unpatentable.

5. Claims 10, 11, 18, and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Harada* in view of *Yamamoto* and *Mochizuki* as applied to claims 1 and 12 above, and further in view of *Kim et al.*, U.S. Patent No. 5,742,370.

Harada does not disclose spin-coating the FLC on, but this is an art-recognized equivalent to the other methods Harada does disclose, as evidenced by Kim which discloses liquid crystal "coated by spin-casting, roll coating, or spray coating method" [col. 3, lines 55-57]. One of ordinary skill in the art would find it obvious to use spin-coating with a rotating substrate, since it is equivalent to the disclosed method. Claims 10, 11, 18, and 19 are therefore unpatentable.

6. Claims 8, 9, 16, and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Harada* in view of *Yamamoto* and *Mochizuki* as applied to claims 7 and 15 above, and further in view of *Abe*, U.S. Patent No. 5,511,591.

Harada does not disclose the details of how the dispenser works; Abe discloses a dispenser which repeatedly moves over the substrate in a preset manner while dispensing liquid crystal, presumably controlled by a preset program. [If not, such automation would be obvious to do. Also, in Abe the substrate moves and the dispenser is fixed; the relative motion is the same, however.] It would be obvious to one

Art Unit: 2871

of ordinary skill in the art to use *Abe's* dispenser with the process of *Harada*, motivated by *Abe*'s teaching that using it "can contribute greatly to productivity improvement because the time for filling is so much reduced" [col. 9, lines 14-17]. Claims 8, 9, 16, and 17 are therefore unpatentable.

7. Claims 2, 13, and 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Harada* in view of *Yamamoto* and *Mochizuki* as applied to claims 1 and 12 above, and further in view of *Asano*, U.S. Patent No. 4,974,940.

Harada does not explicitly disclose the additional limitation of rubbing the orientation films, though this is so conventional one of ordinary skill in the art would likely take it to be inherent in the device of Harada. Regardless, Asano does disclose rubbing the orientation films, and one of ordinary skill in the art would be motivated to do so in the device of Harada by Asano's teaching that "a rubbing method which is excellent for mass production can effectively be used" [col. 10, lines 3-5]. Claims 2, 13, and 20 are therefore unpatentable.

Conclusion

8. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the

Art Unit: 2871

Page 8

shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Schechter whose telephone number is (703) 306-5801. The examiner can normally be reached on Monday - Friday, 9:00 - 5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on (703) 305-3492. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

り Andrew Schechter 17 October 2003

Primary E